

Application/Control No.	Applicant(s)/Patent under Reexamination	
10/717,068	LIM ET AL.	
Examiner	Art Unit	
DANH C. LE	2617	

SEARCHED						
Class	Subclass	Date	Examiner			
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455	90,3	116 07	DL			
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379	110.01					
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INTERFERENCE SEARCHED					
Class	Subclass	Date	Examiner		
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Titerfer	ence Seurch	1/16/07	DL		

SEARCH NOTES (INCLUDING SEARCH STRATEGY)				
	DATE	EXMR		
EAST Search updated (US, USPUB, JPO, EPO, DERWENT)	1/16/07	DL		
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